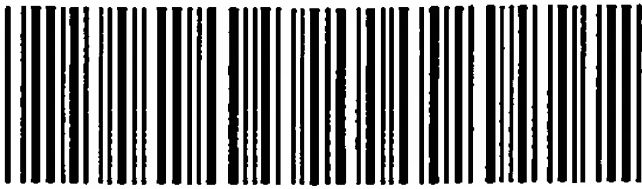


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/619,958	SUGIURA ET AL.	
	Examiner	Art Unit	
	Jacob Y. Choi	2875	

SEARCHED			
Class	Subclass	Date	Examiner
362	26, 561, 621, 622, 612, 626	6/7/2005	JC
362	624, 628	6/7/2005	JC
349	65	6/7/2005	JC
385	146	6/7/2005	JC

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Class/Subclass Search 362, 349, and 385 - Q. Lee	6/7/2005	JC